Electronic Acknowledgement Receipt EFS ID: 1095017 Application Number: 09846119 Confirmation Number: 5235 METHOD OF MAKING A PLANARIZED SEMICONDUCTOR Title of Invention: STRUCTURE First Named Inventor: Yitzhak Gilboa Customer Number: 35617 Filer: Kevin L. Daffer/Pamela Gerik Filer Authorized By: Kevin L. Daffer Attorney Docket Number: 5298-04700 PM00028 Receipt Date: 28-JUN-2006 Filing Date: 30-APR-2001 Time Stamp: 11:08:51 Application Type: Utility International Application Number:

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